

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)ATTY DOCKET NO.
35.G2544APPLICATION NO.
09/519,672APPLICANT
TOSHIHIKO OUCHI ET AL.FILING DATE
March 6, 2000GROUP
2879

JUN 22 2000

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CS	5294790	3/94	Ohta et al.	250	216	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
CS	JP 5-100168	4/93	Japan			Abstract of USP 5294790
CS	JP 8-306062	11/96	Japan			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

CS	U. Dürig et al., "Near-field optical-scanning microscopy ", J. Appl. Phys. <u>59</u> (10) May 1986, pp. 3318-3327.

EXAMINER

Courtney Thomas

DATE CONSIDERED

03.10.02

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

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